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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Radecker Docket No.: INF-141  
Serial No.: 10/798,863 Art Unit: 2811  
Filed: March 12, 2004 Examiner: TBD  
For: Insulator Structure and Method for Producing Insulator Structures in a Semiconductor Substrate

**Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))**

Date of Deposit: August 2, 2004

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IDS Form PTO/SB/08a (1 page) citing (5) references  
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Transmittal of Certified Copy of Priority Document (1 page)  
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Respectfully submitted,

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